

DOCKET NO. 00-654

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

jc903 U.S. PTO
09/884736
06/19/01

In re Application of: Wilbur G. Catabay and)	
Wei-Jen Hsia)	
Filed: Herewith)	
)	Group Art Unit: Unknown
Serial Number: Unknown)	
)	Examiner: Unknown
Title: "Plasma Treatment of Low Dielectric Constant)	
Dielectric Material to Form Structures Useful)	
in Formation of Metal Interconnects and/or)	
Filled Vias for Integrated Circuit Structure")	

FIRST INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.56

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Date: June 19, 2001

Sir:

Pursuant to 37 CFR 1.56, Applicants hereby submit the references listed on the attached form PTO-1449 (modified), which may be relevant to this case. References AB-AF are issued patents assigned to the Assignee of this patent application. Copies of each of the references are enclosed.

Respectfully submitted,

By: John P. Taylor
John P. Taylor
Attorney for Applicants
Registration No. 22,369
(909) 699-7551

Mailing Address:

Gary B. Goates, Manager, IP Services
Intellectual Property Law Department
LSI Logic Corporation
1551 McCarthy Blvd., Mail Stop D-106
Milpitas, CA 95035

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SECOND INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.56

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Date: June 19, 2001

Sir:

Pursuant to 37 CFR 1.56, Applicants hereby submit the references listed on the attached form PTO-1449 (modified), which were previously cited by the USPTO in Office Actions for other patent applications involving low k dielectric material. Copies of each of the references are enclosed.

Respectfully submitted,

By: John P. Taylor
John P. Taylor
Attorney for Applicants
Registration No. 22,369
(909) 699-7551

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